	Application No.	Applicant(s)	
	10/766,665	LEE ET AL.	
Notice of Allowability	Examiner	Art Unit	
	Tung X. Le	2821	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS In herewith (or previously mailed), a Notice of Allowance (PTOL-8: NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT of the Office or upon petition by the applicant. See 37 CFR 1.3:	S (OR REMAINS) CLOSED (5) or other appropriate comm RIGHTS. This application is	n this application. If not included unication will be mailed in due course	e. THIS ne initiative
1. This communication is responsive to amendment filed or	<u>01/31/2006</u> .		
2. ☑ The allowed claim(s) is/are <u>1-11</u> .			
3. ☑ Acknowledgment is made of a claim for foreign priority a) ☑ All b) ☐ Some* c) ☑ None of the:	under 35 U.S.C. § 119(a)-(d)	or (f).	
 Certified copies of the priority documents have 	ve been received.		
Certified copies of the priority documents have	ve been received in Applicati	on No	
3. Copies of the certified copies of the priority of	locuments have been receive	ed in this national stage application fro	om the
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		e a reply complying with the requirem	nents
4. A SUBSTITUTE OATH OR DECLARATION must be sub INFORMAL PATENT APPLICATION (PTO-152) which gi			E OF
5. CORRECTED DRAWINGS (as "replacement sheets") m	ust be submitted.		
(a) I including changes required by the Notice of Draftspe	rson's Patent Drawing Revie	w (PTO-948) attached	
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date	•		
(b) including changes required by the attached Examine Paper No./Mail Date	er's Amendment / Comment o	r in the Office action of	
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in			of
 DEPOSIT OF and/or INFORMATION about the department department regarding REQUIREMENT 			ne
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5 □ Notice of I	nformal Patent Application (PTO-152)	\
 Notice of Preferences Cited (1 10-092) Divide of Draftperson's Patent Drawing Review (PTO-948)) 6. Interview S	Summary (PTO-413),	,
3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB	Paper No 7. ☐ Examiner's	./Mail Dates Amendment/Comment	
Paper No./Mail Date <u>01/27/2004</u>			•
 Examiner's Comment Regarding Requirement for Deposit of Biological Material 	<u></u>	Statement of Reasons for Allowance	5
Don Store	9. 🗌 Other		
DONWONG SUPERVISORY PATENT EXAMINER			

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DETAILED ACTION

1. The amendment filed on January 31, 2006 is acknowledged.

Allowable Subject Matter

2. Claims 1-11 are allowed.

3. The following is an examiner's statement of reasons for allowance:

Regarding claim 1, the prior art discloses an antenna for an inductively coupled plasma generator with a chamber for processing an object received in the chamber with plasma, the antenna comprising a set of at least two loop antenna elements each having a power end for applying radio frequency power thereto and a ground end for connecting to a ground. However, the prior art does not disclose an antenna for an inductively coupled plasma generator comprising a set of at least two loop elements disposed adjacent to one another and in generally parallel relation with one other, each of the loop antenna elements having a lowered portion at a central area between the powered end and the ground end of each of the loop antenna elements are disposed at a location far from the chamber of the plasma generator and the lowered portion of each of the loop antenna elements are disposed at a location closer to the chamber.

Claims 2-3 and 5-11 are allowed since they are dependent on claim 1.

Regarding claim 4, the prior art fails to disclose or fairly suggest an internal antenna and an external antenna, each rectangular shaped, are parallel connected to each other, the internal antenna being installed such that two rectangular antenna elements are symmetrically superposed in two-ply loops, the external antenna being installed such that four L-shaped antenna elements, each having two sides, are

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symmetrically disposed in two-ply loops, and wherein each powered end is disposed farthest from the chamber and each ground end is disposed near to the chamber.

Citation of Relevant Prior Art

4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Chen et al. (U.S. 6,463,875 B1) discloses a multiple coil antenna for inductively coupled plasma generation systems;

Nogami (U.S. 6,436,304 B1) discloses a plasma processing method;

Stimson et al. (U.S. 6,297,595 B1) discloses a method and apparatus for generating a plasma;

Ishii et al. (U.S. 6,350,347 B1) discloses a plasma processing apparatus;

Howald et al. (U.S. 6,842,147 B2) discloses a method and apparatus for producing uniform processing rates;

Podger (U.S. 2003/0234744 A1) discloses a multiloop antenna elements;

Appleyard (U.S. 2003/0201722 A1) discloses a plasma processing apparatus;

Wilcoxson et al. (U.S. 2003/0189524 A1) discloses an antenna for producing uniform process rates; and

Matsuda et al. (U.S. 2002/0018025 A1) discloses a power supply antenna and power supply method.

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Inquiry

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tung X. Le whose telephone number is 571-272-6010. The examiner can normally be reached on 8:30 AM - 5:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Don Wong can be reached on 571-272-1834. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Examiner Tung Le AU 2821

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